PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80222

Hirotaka TANAKA, et al.

Appln. No.: 10/790,111

Group Art Unit: Unknown

Confirmation No.: 1148

Examiner: Unknown

Filed: March 02, 2004

For:

METHOD OF PRODUCING A GLASS SUBSTRATE FOR A MAGNETIC DISK AND

METHOD OF PRODUCING A MAGNETIC DISK

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents, other than any U.S. patents and patent publications, is submitted herewith.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after filing a request for continued examination (RCE) under §1.114, and therefore, no Statement under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/790,111

Q80222

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign

language documents, Applicant submits the following explanations: An English language Abstract

submitted herewith constitutes a concise statement of relevance for JP-2002-30275, which is also cited on

page 1 of the specification.

The submission of the listed documents is not intended as an admission that any such document

constitutes prior art against the claims of the present application. Applicant does not waive any right to

take any action that would be appropriate to antedate or otherwise remove any listed document as a

competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and

the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said

Deposit Account. A duplicate copy of this paper is attached.

Respectfully submitted,

Registration No. 25,426

Alan J. Kasper

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373 CUSTOMER NUMBER

Date: July 20, 2004

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	2004	Com	plete if Known
Substitute for Form 1449 A & B/PTO	JUL 2 0 2004	Application Number	10/790,111
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THE CENTER OF A PRI ICA	NA CAS	Filing Date	March 02, 2004
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		Art Unit	Unknown
(use as many sheets as necessary)		Examiner Name	Unknown
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of

Attorney Docket Number

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	U.S. PATENT DOCUMENTS					
	T	Document Number		Publication Date	Name of Patentee or Applicant of Cited Document	
Examiner Initials*	Cite No.1	Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patence of Applicant of Cited Document	
		US				
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	FOREIGN PATENT DOCUMENTS						
		Foreign Patent Document			Publication Date	Name of Patentee or Applicant of Cited Document	Translation ⁶
Examiner Initials*		MM-DD-YYYY					
	 	JP	2002-30275	Α	01-31-2002	Nihon Microcoating Co. Ltd	Abstract
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		NON PATENT LITERATURE DOCUMENTS	<u></u>
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Examiner Signature	Date Considered

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or follow the hyperlink from the title of the document to the intranet. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ³Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.